

IFW

In re application of

Mail Stop: ISSUE FEE

Takahisa HAYASHI

Confirmation No. 6435

Serial No. 10/699,734

[Group Art Unit 2826

Filed November 4, 2003

Examiner Victor A. Mandala]

SEMICONDUCTOR
DEVICE AND METHOD OF
MANUFACTURING THE SAME

AMENDMENT UNDER 37 CFR 1.312 - AFTER RECEIPT OF NOTICE OF ALLOWANCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Kindly amend the above-identified application as follows.